

09/134,147 5353C1/459003

2/2

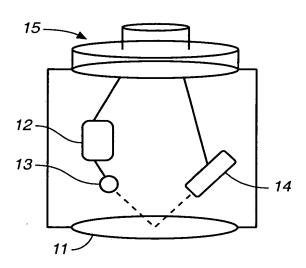


FIG._5

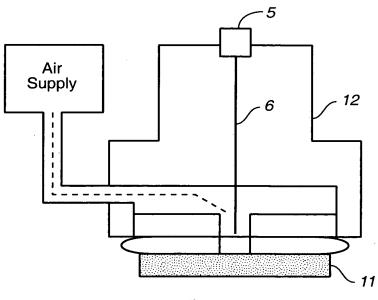


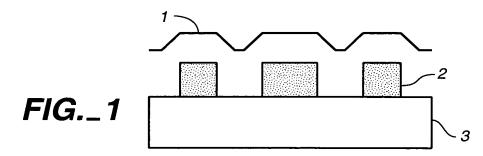
FIG._6

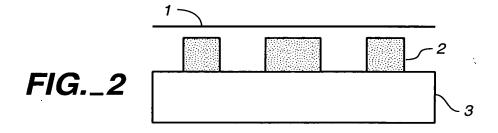


IN-SITU REAL-TIME MONITORING TECHNIQUE AND APPARATUS FOR DETECTION OF THIN FILMS DURING CHEMICAL/MECHANICAL POLISHING PLANARIZATION ... Wallace T.Y. Tang

09/134,147 5353C1/459003

1/2





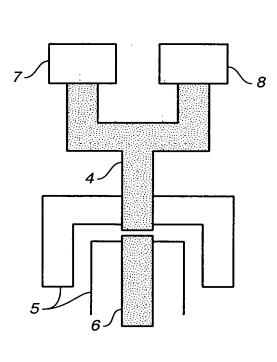


FIG._3

